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PATENT
Customer No. 22,852
Attorney Docket No. 04329.3161

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

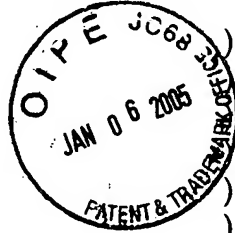
In re Application of:

KENJI KAWANO ET AL.

Application No.: 10/682,419

Filed: October 10, 2003

For: METHOD OF PROCESSING A
SUBSTRATE, HEATING
APPARATUS, AND METHOD OF
FORMING A PATTERN



) Group Art Unit: 2812

) Examiner: Tran, Mai Huong C.

) Confirmation No. 3440

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

Applicants hereby petition for one-month extension of time to respond to the Office Action mailed November 9, 2004. Please charge the fee of \$120.00 to our deposit account 06-0916.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

01/07/2005 AAD0F01 00000113 060916 10682419

01 FC:1251 120.00 DA

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

By: *Richard V. Burgujian*
Richard V. Burgujian #27,432
Richard V. Burgujian
Reg. No. 31,744

Dated: January 6, 2005